



#910
4-15-03
PATENT

Customer No. 22,852
Attorney Docket No. 04788.0247-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

Yasuhiro OMURA)

Application No.: 09/865,734)

Filed: May 29, 2001)

For: PROJECTION OPTICAL SYSTEM,)
EXPOSURE APPARATUS)
INCORPORATING THIS PROJECTION)
SYSTEM, AND MANUFACTURING)
METHOD FOR MICRO DEVICES USING)
THE EXPOSURE APPARATUS)

Group Art Unit: 2851

Examiner: Hung Nguyen

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Commissioner for Patents
Washington, DC 20231

Sir:

AMENDMENT

In reply to the Office Action dated December 4, 2002, the period for reply having been extended for one month to April 4, 2003, by a Request for Extension of Time and fee payment filed concurrently herewith, please amend the application as follows:

ABSTRACT

Please replace the abstract with the abstract suggested on the attached separate sheet.

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